From: Tamara Daw



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shih-Zheng Kuo

REPLY UNDER 37 CFR 116 EXPEDITED PROCEDURE

Technology Center 2600

Application No.: 10/005,784

Filed:

November 08, 2001

For:

STAGGER SENSER AND

METHOD FOR IMPROVING

MODULATION

Examiner: Safaipour, Houshang

Art Unit: 2625

Response Under 37 CFR 116(b)

Mail Stop AF COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Please enter the following amendments and consider the following remarks.

Amendments begin on page 2.

Remarks begin on page 6.

Please pankilob